



2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213
T 202.293.7060
F 202.293.7860
www.sughrue.com

MAIL STOP PATENT APPLICATION

July 3, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Application of Masato SHIMADA and Tetsushi TAKAHASHI
METHOD OF MANUFACTURING A LIQUID-JET HEAD
Assignee: **SEIKO EPSON CORPORATION**
Our Ref. Q76433

Dear Sir:

Attached hereto is the application identified above comprising twenty (20) sheets of the specification, including the claims and abstract (in Japanese language) and nine (9) sheets of drawings. **The requisite Government Filing Fee, executed Declaration and Power of Attorney, Assignment, and an English translation of the Application will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	13 - 20	=		x	\$18.00	=	\$0.00
Independent claims	1 - 3	=		x	\$84.00	=	\$0.00
Base Fee							\$750.00
TOTAL FEE							\$750.00

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07/03/03



SUGHRUE MION, PLLC

Attorney Docket No: Q76433

Filing Date: July 3, 2003

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Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
JAPAN	2002-196288	July 4, 2002
JAPAN	2002-197337	July 5, 2002
JAPAN	2003-191367	July 3, 2003

The priority documents will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By:


Darryl Mexic

Registration No. 23,063

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

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